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TO NAME <u>EXAMINER NGAN NGO</u> COMPANY/FIRM <u>U.S. PTO</u> NUMBER OF PAGES INCLUDING COVER: <u>10</u>	JANUARY 22, 2004 DATE <u>571-273-1711</u> FAX # CONFIRM FAX: <input type="checkbox"/> YES <input type="checkbox"/> NO
FROM NAME <u>Debbie Sierra</u> DIRECT PHONE # <u>703-412-1797</u>	<u>219723US-2S</u> OUR REFERENCE <u>10/078,344</u> YOUR REFERENCE

MESSAGE

Pursuant to a telephone conversation, enclosed is a copy of the amendment filed November 10, 2003 (signed so as to be considered an original), along with the date-stamped filing receipt evidencing the filing thereof.

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OSMM&N File No. 219723US-2S

Dept.: E/M

Serial No. 10/078,344

By: EHK/DAB/des

In the matter of the Application of: Heiime NAGANO ET AL.

For: SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND
MANUFACTURING METHOD THEREOF

Due Date: 11/08/03

The following has been received in the U.S. Patent Office on the date stamped hereon:

- ☐ Dep. Acct. Order Form
- ☒ Letter/Cover
- ☒ Amendment



Docket No. 219723US-2S

IN RE APPLICATION OF: Hajime NAGANO ET AL.

SERIAL NO: 10/078,344

FILED: FEBRUARY 21, 2002

FOR: SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND MANUFACTURING METHOD THEREOF

RESPONSE UNDER 37 CFR 1.118-
EXPEDITED PROCEDURE EXAMINING
GROUP 2814COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

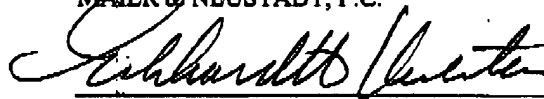
Transmitted herewith is an amendment in the above-identified application.

- ☒ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS	
TOTAL	8	MINUS	25	0	x \$18 =	\$0.00	
INDEPENDENT	2	MINUS	3	0	x \$86 =	\$0.00	
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$290 =	\$0.00	
		TOTAL OF ABOVE CALCULATIONS					\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity					\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00	
		TOTAL					\$0.00

- ☐ A check in the amount of \$0.00 is attached.
- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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DOCKET NO: 219723US-2S

*RESPONSE UNDER 37 CFR 1.118-
EXPEDITED PROCEDURE EXAMINING
GROUP 2814

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

HAJIME NAGANO ET AL. :

: EXAMINER: NGO, N.

SERIAL NO: 10/078,344 :

FILED: FEBRUARY 21, 2002 :

: GROUP ART UNIT: 2814

FOR: SEMICONDUCTOR DEVICE
USING PARTIAL SOI SUBSTRATE AND
MANUFACTURING METHOD THEREOF

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 8, 2003, please amend the above-
identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.